



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hogan et al.
Appln. No.: 10/635,824
Filed: 08/06/2003
For: Method for Improving Ash Rate Uniformity in Photoresist Ashing Process Equipment

Docket No.: TI-28996.1

Art Unit: 3742

Examiner: Van, Q.

Conf. No.: 7653

ELECTION

April 7, 2004
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(A)	
I hereby certify that the above correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date below.	
Sue Short	Date
Sue Short 4/12/2004	

Examiner:

In response to the Office Action mailed March 31, 2004, Applicants hereby elect to pursue Group I: Claims 1-12 in the above-referenced application.

Respectfully submitted,

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